

KANEKO. 014AUS



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Minoru Umemoto et al. ) Group Art Unit  
Serial No. : 10/585,707 )  
Filed : July 10, 2006 )  
For : PROCESS OF FORMING )  
ULTRAFINE CRYSTAL LAYER, )  
MACHINE COMPONENT HAVING )  
ULTRAFINE CRYSTAL LAYER )  
FORMED BY THE ULTRAFINE )  
CRYSTAL LAYER FORMING )  
PROCESS, PROCESS OF )  
PRODUCING THE MACHINE )  
COMPONENT, PROCESS OF )  
FORMING NANOCRYSTAL LAYER, )  
MACHINE COMPONENT HAVING )  
NANOCRYSTAL LAYER FORMED )  
BY THE NANOCRYSTAL LAYER )  
FORMING PROCESS, AND )  
PROCESS OF PRODUCING THE )  
MACHINE COMPONENT )  
Examiner : Christopher S. Kessler )  
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ELECTION & AMENDMENT

Hon. Commissioner  
of Patents and Trademarks  
Alexandria, VA 22313-1450

Dear Sir:

This election and amendment is submitted for the above-identified patent application in response to the office action from the United States Patent and Trademark Office mailed October 5, 2009. Please make the following election and changes:

**Serial No. : 10/585,707**  
**Filed : July 10, 2006**

**ELECTION:**

In response to the restriction requirements, the applicant elects the group I invention directed to the ultrafine crystal layer forming process for further prosecution of this case. The elected invention is readable on Claims 16-23 and 38.